Confirmation No.: 6062

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/808,692

Applicant(s): Ogihara et al. Filed: 03/25/2004 Art Unit: 2891

Examiner: A. Sarkar

Title: COMPOSITION FOR FORMING POROUS FILM, POROUS FILM

AND METHOD FOR FORMING THE SAME, INTERLEVEL INSULATOR

FILM AND SEMICONDUCTOR DEVICE

Docket No.: 035576/276101

Customer No.: 00826

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT

Sir:

In response to the Office Action dated January 31, 2007, please consider the following remarks:

Amendments begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.